

Electronic Patent Application Fee Transmittal

Application Number:	10595660			
Filing Date:	03-May-2006			
Title of Invention:	High purity hafnium, target and thin film comprising said high purity hafnium, and method for producing high purity hafnium			
First Named Inventor/Applicant Name:	Yuichiro Shindo			
Filer:	William Bak			
Attorney Docket Number:	OGOSH53USA			

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
-------------	----------	----------	--------	----------------------

Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Notice of appeal	1401	1	620	620
------------------	------	---	-----	-----

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				620